

<b>Notice of References Cited</b>	Application/Control No. 10/631,087	Applicant(s)/Patent Under Reexamination BERNSTEIN ET AL.	
	Examiner William C. Choi	Art Unit 2873	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0081070 A1	06-2002	Tew, Claude E.	385/39
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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